Claims

[c1] What is claimed is:

 A wafer holder for semiconductor manufacturing devices, the wafer holder having a wafer-carrying surface and comprising:

a shaft joined to the wafer holder for supporting the wafer holder;

an electrical circuit formed either on a surface other than the wafer-carrying surface of the wafer holder, or else inside it; and

electrodes within said shaft, for supplying power to said electrical circuit, the heat capacity of said electrodes where they are within said shaft being 10% or less of the heat capacity of a region of the wafer holder that corresponds to inside the outer periphery of said shaft.

- [c2] 2. The wafer holder set forth in claim 1, wherein the electrical circuit formed in the wafer holder is at least a resistive heating element.
- [c3] 3. A semiconductor manufacturing device wherein the wafer holder set forth in claim 1 is installed.
- [c4] 4. A semiconductor manufacturing device wherein the wafer holder set forth in claim 2 is installed.

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